

05/27/2008

**REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 1700**

Attorney's Docket No. 015675.P568

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for:

Bernard Beaumont, et al.

Application No. 10/522,397

Filed: October 21, 2005

For: **METHOD FOR PRODUCING BY
VAPOUR-PHASE EPITAXY A GALLIUM
NITRIDE FILM WITH LOW DEFECT
DENSITY**

Examiner: Marissa W. Chaet

Art Unit: 1791

Confirmation No.: 6314

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

In response to the Final Office Action dated March 18, 2008, Applicants submit the following amendments and remarks: